

# PATENT ABSTRACTS OF JAPAN

(11)Publication number : 09-138410  
 (43)Date of publication of application : 27.05.1997

(51)Int.CI.

G02F 1/1337

(21)Application number : 07-294456  
 (22)Date of filing : 13.11.1995

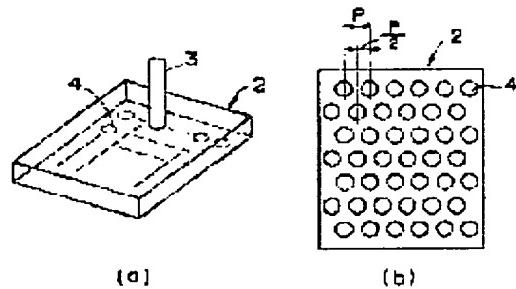
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## (54) FORMING METHOD OF ORIENTED FILM FOR LIQUID CRYSTAL DISPLAY ELEMENT

### (57)Abstract:

**PROBLEM TO BE SOLVED:** To provide a forming method of an oriented film for a liquid crystal display element so that an oriented film having uniform film thickness can be formed by arranging injection holes in such a manner that one line of injection holes is dislocated by a half pitch of nozzles from the adjacent line of injection holes.

**SOLUTION:** The ink jet nozzle 2 used is an area-type one to inject a soln. to form an oriented film. The diameter of the injection hole 4 is, for example, 50 $\mu$ m and the pitch ( $p$ ) of injection holes 4 in one line is, for example, 100 $\mu$ m. One line of injection holes is arranged as dislocated by a half pitch ( $p/2$ ) to the adjacent line. By this method, a problem of irregular thickness due to variation in overlap amt. of liquid drops is prevented compared to a conventional method in which a line-type ink jet nozzle is used and a coating liquid is applied by controlling the relative velocity between an ink jet nozzle and a substrate or the timing of coating.



### LEGAL STATUS

[Date of request for examination]

[Date of sending the examiner's decision of rejection]

[Kind of final disposal of application other than the examiner's decision of rejection or application converted registration]

[Date of final disposal for application]

[Patent number]

[Date of registration]

[Number of appeal against examiner's decision]

of rejection]

[Date of requesting appeal against examiner's  
decision of rejection]

[Date of extinction of right]

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